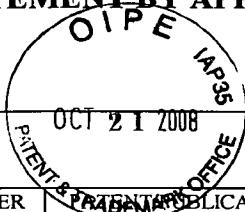


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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449 | Docket No. 52433/795 | Application No. 10/534,858 | |
| | Applicant(s) HASHIMURA et al. | Examiner Deborah Yee | |
| | Filing Date May 13, 2005 | Confirmation No. 9080 | Art Unit 1793 |



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| EXAMINER /Deborah Yee/ | DATE CONSIDERED 11/27/2008 |
| EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |